



**ELECTRONIC COPY**

LG792664640  
Report verification at igi.org



June 4, 2026  
IGI Report Number **LG792664640**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MODIFIED MARQUISE STEP CUT**  
Measurements **22.00 X 12.52 X 7.91 MM**  
**GRADING RESULTS**  
Carat Weight **13.10 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

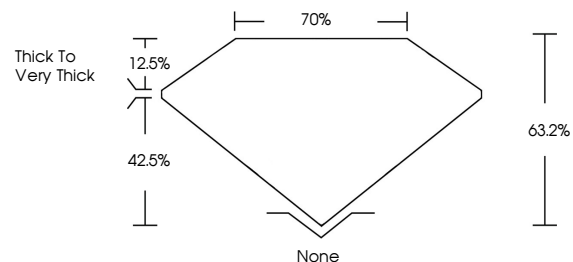
Carat Weight **13.10 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG792664640**

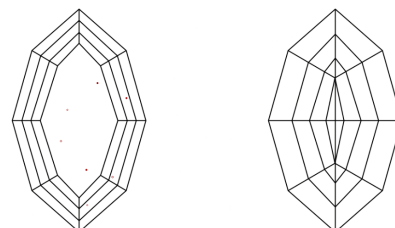
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

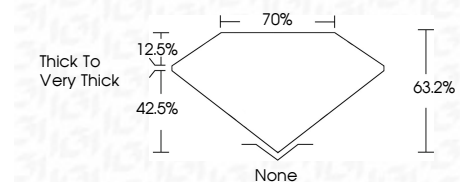
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**MODIFIED MARQUISE STEP CUT**  
**22.00 X 12.52 X 7.91 MM**  
**13.10 CARATS**  
**F**  
**VVS 2**  
**63.2%**  
**70%**  
**Thick to Very Thick**  
**None**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG792664640**  
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Type IIa